

17607 U.S. PTO
09/19/03

Inventors: Jer-Shen Maa, Jong-Jan Lee, Douglas J. Tweet, and Sheng Teng Hsu

Title: METHOD OF MAKING RELAXED SILICON-GERMANIUM ON INSULATOR VIA LAYER TRANSFER

No. of pages in Specification: 15 No. of Claims: 21

No. of sheets of Drawings: 3 Formal: Informal: X

Also enclosed are:

- X A Declaration.
- X An Assignment and Recordation Form Cover Sheet.
- X Power of Attorney by Assignee.
- A certified copy of a priority application.
- A Verified Statement to establish small entity status.
- An Information Disclosure Statement under 37 C.F.R. §1.56.

22141 U.S. PTO
10/665944
09/19/03

The filing fee pursuant to 37 C.F.R. §1.16 is determined as follows:

	No. Filed	No. Extra	Rate		
Basic Fee			\$750.00	=	\$ 750.00
Total Claims	<u>21</u> - 20	1	X \$18.00	=	\$ 18.00
Independent Claims	<u>3</u> - 3	0	X \$84.00	=	\$ 0.00
First Presentation of Multiple Dependent Claim(s) (0)		0	X \$280.00	=	\$ 0.00
Total					\$ 768.00

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Any additional filing fees under 37 C.F.R. § 1.16.

Any patent application processing fees under 37 C.F.R. § 1.17.


Correspondence Address

In accordance with 37 C.F.R. §1.34(a), please direct all correspondence in this application to the following:

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September 19, 2003
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

PATENT APPLICATION

Inventors: Jer-Shen Maa, Jong-Jan Lee,
Douglas J. Tweet, and Sheng Teng
Hsu

Serial No: Not Yet Assigned

Attorney Docket No.
SLA0774

Filed: Herewith

Title: METHOD OF MAKING RELAXED
SILICON-GERMANIUM ON
INSULATOR VIA LAYER
TRANSFER

Assignee: Sharp Laboratories of America, Inc.

**CERTIFICATE OF MAILING BY "EXPRESS MAIL"
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